ASMMC.9CP1DV1C1 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

: Arthur Sherman

Appl. No.

10/683,727

Filed

October 10, 2003

For

SEQUENTIAL CHEMICAL

VAPOR DEPOSITION

Examiner

Kelly M. Stouffer

Group Art Unit

1762

Confirmation No.:

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CERTIFICATE OF EFS WEB TRANSMISSION

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October 9, 2008

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action dated July 9, 2008, and is accompanied by a request for continued examination.

Amendments to the Claims begins on page 2 of this paper.

Summary of Interview begins on page 3 of this paper.

Remarks/Arguments begin on page 4 of this paper.